



GAu 28124

PATENT

0756-1936

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of) Group Art Unit: 2812
Shunpei YAMAZAKI et al.) Examiner: R. Booth
Serial No. 09/255,777)
Filed: February 23, 1999)
For: SEMICONDUCTOR DEVICE)
AND METHOD FOR)
FORMING THE SAME)
CERTIFICATE OF MAILING
I hereby certify that this correspondence was placed in the U.S.)
States Postal Service with sufficient postage and is being sent to the)
addressed to: Assistant Commissioner for Patents
on: June 7, 2001
MAY 2001

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on:

June 7, 2000.

Melissa McKibben

Transmittal

Assistant Commissioner for Patents
Washington, D.C. 20231

June 7, 2000

Sir:

Transmitted herewith is **an Amendment** in the above-identified application.

The fee has been calculated as shown below:

	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Small/Large Entity Rate	Fee
Total	59	Minus	33	26	X \$18.00	\$468.00
Indep.	12	Minus	6	6	X \$78.00	\$468.00
First Presentation of Multiple Dependent Claim					\$260.00	\$0.00
TOTAL						\$936.00

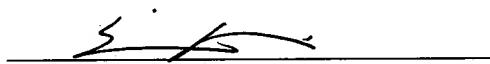
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JUN 13 2009

- A check in the amount of **\$936.00** is enclosed for the fees associated with additional claims.
- In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380.
- The Commissioner is hereby authorized to charge fees under 37 CFR 1.16, 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380. **A duplicate copy of this sheet is attached.**

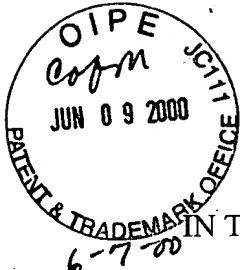
Respectfully submitted,

NIXON PEABODY LLP


Eric J. Robinson
Registration No.: 38,285.

EJR:mmc

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McLean, Virginia 22102
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#61B
6-15-00
R. Hader

PATENT

0756-1936

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shunpei YAMAZAKI et al.

Serial No. 09/255,777

Filed: February 23, 1999

For: SEMICONDUCTOR DEVICE
AND METHOD FOR
FORMING THE SAME

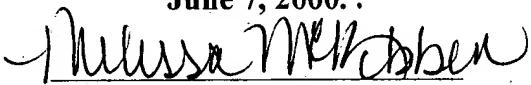
Group Art Unit: 2812

Examiner: R. Booth

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June 7, 2000.


Melissa McKibben

AMENDMENT

Assistant Commissioner for Patents
Washington, D. C. 20231

June 7, 2000

Sir:

In response to the Office Action mailed March 7, 2000, please amend the above-identified application as follows:

In the claims:

Please cancel claims 20 and 25.

Please amend the claims as follows:

1. (Amended) A method for fabricating a semiconductor device, comprising the steps of:

~~forming a semiconductor film comprising amorphous silicon on an insulating surface;~~

~~forming an insulating film on said semiconductor film;~~

~~introducing boron into at least a portion of said semiconductor film through~~

06/12/2000 CVDRACHA 00000013 09255777

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02 FC:102

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